IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Van Beek, et al.

Docket No.:

EPC-019

Serial No.:

10/578,026

Art Unit:

2829

Filed:

March 13, 2007

Examiner:

Ming Hung Hung

Title:

Method of Manufacturing an Electronic Device and Electronic Device

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

The Applicants wish to bring to the attention of the U.S. Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a which may be considered material to the examination of the above-identified application. A copy of the U.S. Patent cited is not being submitted. However, the Applicants have included a copy of the foreign patent.

This Information Disclosure Statement is submitted under 37 C.F.R. §1.97(c) together with a \$180.00 fee under 37 C.F.R. §1.17(p) after the C.F.R. §1.97(b) time period, but before final action or notice of allowance, whichever occurs first.

Please charge the required fee of \$180.00 and any additional amount, or credit any overpayment to Deposit Acct. No. 50-1065 of the below mentioned firm.

Date

Respectfully submitted,

Ira S. Matsil

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